



Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty. Docket No. SCHO0056	Serial No.: 09/873,455
	Applicant: Staehler et al. Filing Date: June 4, 2001	Group: 2811

RECEIVED
TC 2803 MAIL ROOM

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
12/12	A	6,153,076	11/28/2000	Davidson et al.	204	601	01/12/1998
12/12	B	5,783,452	07/21/1998	Jons et al.	436	183	02/02/1996

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	C	19940750	08/27/1999	Germany	33	48		X

RECEIVED
APR 19 2002
TC 1700

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
12/12	D	Chr. Burrer, and J. Esteve, <u>High-Precision BESOI-based Resonant Accelerometer</u> ; Sensors and Actuators; Elsevier Science S.A.; 1995
12/12	E	A. Benitez, J. Esteve, and J. Bausells; <u>Bulk Silicon Microelectromechanical Devices Fabricated From Commercial Bonded and Etched-Back Silicon-On-Insulator Substrates</u> ; Sensors and Actuators; Elsevier Science S.A.; 1995

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Form 1449 (Modified)	Atty. Docket No. SCHO0056	Serial No.: 09/873,456
Information Disclosure Statement By Applicant	Applicant: Staehler et al.	Group: 2811
(Use Several Sheets if Necessary)	Filing Date: June 4, 2001	

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	5,498,392	3/12/96	Wilding et al.	422	69.1	9/19/94
	B	5,744,366	4/28/98	Kricka et al.	436	63	11/14/94

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	C	WO 96/41864	12/27/96	PCT	C12M	1/02	X	
	D	WO 00/11477	3/2/00	PCT	G01N	33/60		X

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.